

10/531434  
10-1449 Equivalent

**LIST OF PRIOR ART CITED BY APPLICANT**

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Applicant(s): **Kazunari KURITA** and **Jun FURUKAWA**

Application No. 10/531,484 (Int'l Appln No. PCT/JP2003/013320 17OCT03) Group: 1320

, Filed: 02/14/2000

Examiner: Hiteshew

## **U.S. PATENT DOCUMENTS**

DISCOVERY DOCUMENTS							
Exam. Init		Document Number	Date	Name	Class	Sub- Class	Filing Date Appropriate
Kit	AA	6,045,610	04/04/2000	Park, et al.	—	—	—
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

FOREIGN PARENT DOCUMENTS							
		Document Number	Date	Country	CLASS	Sub-Class	Translation
							YES
F.H.	AL	2 324 652	10/28/1998	Great Britain	—	—	—
F.H.	AM	11-1393	06/01/1999	Japan	—	—	US 6,045,610
F.H.	AN	2002-47094	02/12/2002	Japan	—	—	Abstract only
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						

**OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

<i>Fitt</i>	AX	Abstract only of Publication No. 2002-102385 published 13APR01, Mitsubishi Materials Silicon, "Silicon wafer without aggregate of dot-like defect"
	AY	
	AZ	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include any of this form with next communication to applicant.